

2-14-98
JLB

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of: Wilk *et al.* Docket: TI-24742
Provisional Serial No. 60/063,010 Examiner: TBD
Serial No.: TBD Art Unit: TBD
Provisional Filed: 10/23/97
Filed: Herewith
For: Low Temperature Method for Forming a Thin, Uniform Oxide

jc518 U.S. PTO
09/176422
10/21/98



INFORMATION DISCLOSURE STATEMENT

October 21, 1998

Assistant Commissioner For Patents
Washington, D. C. 20231

MAILING CERTIFICATE UNDER 37 CFR § 1.8
I hereby certify that this correspondence is being deposited with the
United States Postal Service as first class mail in an envelope addressed
to: Assistant Commissioner for Patents, Washington, DC 20231 on

10/21/98, 1998.

Sue Short
Sue Short

Examiner:

Applicants wish to bring to the attention of the Patent and Trademark Office the information noted on the enclosed PTO-1449.

Copies of reference(s) AA and AG are enclosed. Applicants believe that no fee is due. However, the Commissioner is authorized to charge any necessary fee to Deposit Account 20-0668.

Respectfully submitted,



David Denker
Reg. No. 40,987

Texas Instruments Incorporated
P. O. Box 655474, MS 3999
Dallas, Texas 75265
(972) 917-4388
Fax (972) 917-4418